

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Ryouji HIROYAMA, et al.**

Serial No.: **NEW APPLICATION**

Filed: **September 25, 2000**

For: **SEMICONDUCTOR LASER DEVICE AND METHOD OF MANUFACTURING  
THE SAME**

INFORMATION DISCLOSURE STATEMENT

Director of Patents and Trademarks  
Washington, D.C. 20231

September 25, 2000

Sir:

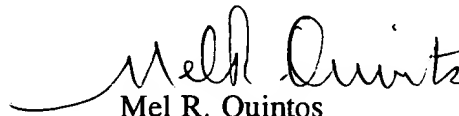
In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

Copies of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

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Respectfully submitted,  
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Enclosures: PTO-1449; Reference (4)

#3 / 1DS  
11-21-00  
R. J. J. J.

